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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

**OZAKI, Takashi, et al.**

Group Art Unit: 1763

Serial No.: **10/528,137**

Examiner: **Sylvia MacArthur**

Filed: **December 12, 2005**

P.T.O. Confirmation No.: **2307**

For: **SUBSTRATE PROCESSING APPARATUS AND METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: August 27, 2007

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated July 18, 2007 for one month, from August 18, 2007 to September 18, 2007.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 in the amount of \$120.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP

Mel R. Quintos

Attorney for Applicants  
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08/28/2007 MAHMED1 00000067 012340 10528137  
01 FC:1251 120.00 DA

MRQ/lrj

Atty. Docket No. **050161**  
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**23850**

PATENT TRADEMARK OFFICE